

Notice of References Cited	Application/Control No. 09/775,715	Applicant(s)/Patent Under Reexamination ABROL ET AL.	
	Examiner Chongshan Chen	Art Unit 2172	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,855,015	12-1998	Shoham, Yoav	707/5
	B	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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